



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ji Won KIM, Young Soo KIM and In Kyu KIM

Group Art Unit: 3749

Serial No.:

09/927,466

Filed: August 13, 2001

: Confirm. No.: 6144

For:

CONTROL METHOD OF AIR/GAS RATIO IN GAS FURNACE

REPLY TO NOTICE TO FILE CORRECTED APPLICATION PAPERS FILING DATE GRANTED

Assistant Commissioner of Patents

Washington, D. C. 20231

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W.H.W.

Sir: In reply to the Notice to File Corrected Application Papers dated September 17, 2001, submitted herewith are the following documents for filing in the above-referenced application:

1. Substitute abstract in compliance with 37 CFR §1.72(b).

2. Copy of Notice to File Corrected Application Papers.

It is requested that an Official Filing Receipt showing the data contained herewith now be issued.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 16-0607 and please credit any excess fees to such deposit account.

> Respectfully submitted, FLESHNER & KIM, LLP

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